



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/484,421 Confirmation No. :
Applicant : MARTIN DUBS, et al.
Filed : January 18, 2000
TC/A.U. : 1745
Examiner :
Docket No. : 622/48561
Customer No. : 23911
Title : SPUTTER CHAMBER AS WELL AS VACUUM
TRANSPORT CHAMBER AND VACUUM HANDLING
APPARATUS WITH SUCH CHAMBERS

MAR 01 2004

REPLY UNDER 37 C.F.R. §1.111

Mail Stop Non Fee

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following remarks are respectfully submitted in response to the Office

Action dated October 21, 2003.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.